

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Confirmation No. 5632

**Brian W. Baird, Michael J. Wolfe, Richard S. Harris,
Kevin P. Fahey, Lian-Cheng Zou, and Thomas R. McNeil**

Group Art Unit: 1732

Application No. 10/017,497

Filed: December 14, 2001

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**For: ULTRAVIOLET LASER ABLATIVE PATTERNING
OF MICROSTRUCTURES IN SEMICONDUCTORS****OFFICE OF PETITIONS**

Examiner: Dr. Stefan Staicovici

Date: April 11, 2006

PETITION TO WITHDRAW FROM ISSUE UNDER 37 CFR 1.313(c)**TO THE COMMISSIONER FOR PATENTS:**

Applicant hereby petitions that the above-identified application be withdrawn from issue for the purpose of considering the enclosed Request for Continued Examination. 37 CFR 1.313(c)(2).

Applicant requests expedited notification of the granting or denial of this petition. Please send notice by facsimile to the undersigned at (503) 220-2480 or by e-mail to mllevine@stoel.com.

Respectfully submitted,

**Brian W. Baird, Michael J. Wolfe,
Richard S. Harris, Kevin P. Fahey,
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By



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COMMENTS:

Re: U.S. Patent Application No. 10/017,497
Filed: December 14, 2001
For: ULTRAVIOLET LASER ABLATIVE
PATTERNING OF MICROSTRUCTURES
IN SEMICONDUCTORS
Our Docket No. 50001/83:2 USA